

Notice of References Cited	Application/Control No. 10/687,424	Applicant(s)/Patent Under Reexamination LIAW, JHON JHY	
	Examiner Kin-Chan Chen	Art Unit 1765	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2004/0241981	12-2004	Doris et al.	438/637
	B	US-6,225,147	05-2001	Noble, Wendell P.	438/149
	C	US-6,004,831	12-1999	Yamazaki et al.	438/30
	D	US-6,465,296	10-2002	Quek et al.	438/233
	E	US-5,610,083	03-1997	Chan et al.	438/155
	F	US-5,219,783	06-1993	Moslehi, Mehrdad M.	438/420
	G	US-5,039,621	08-1991	Pollack, Gordon P.	438/164
	H	US-6,657,261	12-2003	Assaderaghi et al.	257/354
	I	US-6,100,151	08-2000	Park, Kang-Wook	438/318
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.